



PATENT  
3885-0103P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant:	Yoshinobu Ono et al.	Conf.:	2546
Appl. No.:	10/046,741	Group:	2812
Filed:	January 17, 2002	Examiner:	S. Mulpuri
For:	METHOD FOR FABRICATING III-V COMPOUND SEMICONDUCTOR		

**AMENDMENT UNDER 37 C.F.R. § 1.111**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

July 19, 2004  
(Monday)

Sir:

In reply to the Office Action dated March 18, 2004, the period for response having been extended by one (1) month until July 18, 2004, the following amendments and remarks are respectfully submitted in connection with the above-identified application.

This reply includes amendments to the specification, a declarataion and remarks.